

<b>Notice of References Cited</b>	Application/Control No. 10/700,096	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Michael Pervan	Art Unit 2629	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,816,139	11-2004	Park, Kwan-seon	345/87
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	K	US-			
	L	US-			
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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